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**RESPONSE UNDER 37 C.F.R. § 1.116
-- EXPEDITED PROCEDURE --
EXAMINING GROUP 2800**

Our Docket No: 42P13230D

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Shafquat Ahmed et al.

Serial No: 10/619,961

Filed: July 15, 2003

For: Method of Forming Transistor Having
Insulating Spacers On Gate Sidewalls

Examiner: Booth, Richard

Art Unit: 2812

RESPONSE TO FINAL OFFICE ACTION

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed August 31, 2005, the Applicants respectfully request that the Examiner enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that I am causing the above-referenced correspondence to be deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and that this paper or fee has been addressed to the Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

November 30, 2005

Date of Deposit

Krista Mathieson

Name of Person Mailing Correspondence

Krista Mathieson
Signature

November 30, 2005
Date